



**TEL - Tokyo Electron  
Certas LEAGA RST (Etch Chamber)  
Serial nr PJ1015  
Vintage Nov 2018 300mm**

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**Location Nijmegen the Netherlands**

### Condition "As is"

Certas™ is a series of environment-friendly, high-throughput gas chemical etch systems. Designed to deliver optimal solutions for advanced devices, Certas™ offers high etch selectivity, high uniformity, and excellent removal of residue and roughness.

This process chamber is in as good as new condition only used in R&D environment.



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